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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: MASUDA et al
Serial No.: 10/647,319
Filed: August 26, 2003
For: Plasma Etching Apparatus
Art Unit: 1763
Examiner: L. Alejandro Mulero

AMENDMENT

Mail Stop: Amendment (Fee)
Commissioner For Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 14, 2005

Sir:

The following amendments and remarks which accompany the RCE are respectfully submitted in connection with the above-identified application, in response to the Office Action dated September 14, 2004. The amendments are listed below and set forth on the following pages.

Amendments to the Claims; and

Remarks are included following the amendments.